WAKAB85.001AUS PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicant** 

Soichi Saito et al.

App. No

: 10/766,068

Filed

: January, 28, 2004

For

: METHOD FOR MEASURING BY MEANS OF CHEMICAL SENSOR,

AND CHEMICAL SENSOR TYPE

**MEASURING APPARATUS** 

Examiner

: Kaj K. Olsen

Art Unit

: 1795

Conf No.

: 2422

## AMENDMENT AFTER FINAL

## Mail Stop AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## Dear Sir:

In response to the Office Action dated May 5, 2009, Applicants respectfully submit the following amendments and remarks in connections with the above captioned application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 9 of this paper.